

RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1763

PATENT

Customer No. 22,852 Attorney Docket No. 7553.0019-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		
Chishio KOSHIMIZU et al.) Group Art Unit: 1763
Application No.: 10/675,966) Examiner: KACKAR, RAM N
Filed:	October 2, 2003))
For:	PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD) Confirmation No. 6290)

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the final Office Action mailed March 7, 2005, the period for response having been extended to September 7, 2005 by a Petition for Extension of Time - Three Months and appropriate fee payment, and pursuant to 37 C.F.R. § 1.116, Applicants respectfully request that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.